

Electronic Patent Application Fee Transmittal

Application Number:	09964648			
Filing Date:	28-Sep-2001			
Title of Invention:	Exposure apparatus, semiconductor device manufacturing method, exposure apparatus maintenance method and semiconductor manufacturing factory			
First Named Inventor/Applicant Name:	Keiji Yoshimura			
Filer:	Lawrence A. Stahl			
Attorney Docket Number:	862.C2397			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	790	790
Total in USD (\$)				790